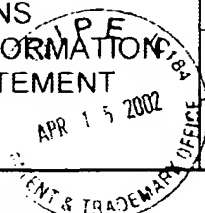


LIST OF PATENTS AND
PUBLICATIONS
FOR APPLICANTS INFORMATION
DISCLOSURE STATEMENT

APPLICANT Bernas et al.

FILING DATE 10/31/01

GROUP TO 1731
~~BE ASSIGNED TBA~~

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
CF	AA	2001/0028462	10/11/01	Ichihara et al.	—	—	—
CF	AB	5,204,055	4/20/93	Sachs et al.	—	—	—
CF	AC	5,387,380	2/7/95	Cima et al.	—	—	—
CF	AD	5,479,257	12/26/95	Hashimoto	—	—	—
CF	AE	5,530,257	6/25/96	Mizutani et al.	—	—	—
CF	AF	5,623,853	4/29/97	Novak et al.	—	—	—
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CF	AJ	6,036,777	3/14/00	Sachs	—	—	—
CF	AK	6,188,150	2/13/01	Spence	—	—	—

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							
	AQ							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

CF			"Extreme Ultraviolet Lithography." Gwyn, C., et al., EUV LLC, Nov. 1999, pps. 97-141.
	AR		
CF			"Three Dimensional Printing." website: http://web.mit.edu/tdp/www/applications.html
	AS		
	AT		

EXAMINER:

ca 702

DATE CONSIDERED:

11/26/03

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement-PTO-1449 (Modified)